,	Search .	Notes	

Application/Control No.	Applicant(s)/Patent under Reexamination
10/603,989	YONEZAWA, MINORU
Examiner	Art Unit
Nathan Danielsen	2627

	SEAR	CHED	
Class	Subclass	Date	Examiner
			, X
:			

INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
		•		

DATE 2/28/2007	EXMR ND
2/28/2007	ND